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PATENT
RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 1742

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Christa M. Thorpe

Appl No. : 10/731,710 Confirmation No. 5454
Applicant : Xian Yao, et al.
Filed : December 9, 2003
Title : METHOD FOR FORMING ULTRA HARD SINTERED COMPACTS
USING METALLIC PERIPHERAL STRUCTURES IN THE SINTERING
CELL
TC/A.U. : 1742
Examiner : Daniel J. Jenkins
Docket No. : 50547/M277
Customer No. : 23363

RESPONSE TO FINAL REJECTION

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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Post Office Box 7068
Pasadena, CA 91109-7068
March 24, 2006

Commissioner:

In response to the Office Action of January 27, 2006, please amend the above-identified application as follows:

Remarks/Arguments begin on page 2 of this paper.